Electronic Acknowledgement Receipt				
EFS ID:	1445407			
Application Number:	10798144			
International Application Number:				
Confirmation Number:	5533			
Title of Invention:	Method of depositing ALD thin films on wafer			
First Named Inventor/Applicant Name:	Young Hoon Park			
Customer Number:	23413			
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl
1	Information Disclosure Statement (IDS) Filed	US_IDS_FormSB_08a.pdf	719235	no	4
Warnings:					
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2	Foreign Reference	Foreign_Reference_1_YPL- 0085.pdf	734684	no	6
Warnings:					
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3	Foreign Reference	Foreign_Reference_2_YPL- 0085.pdf	2733292	no	15
Warnings:					
Information:					
4	Foreign Reference	Foreign_Reference_3_YPL- 0085.pdf	847406	no	6
Warnings:				•	
Information:					
5	Foreign Reference	Foreign_Reference_4_YPL- 0085.pdf	536863	no	4
Warnings:					
Information:					
6	Foreign Reference	Foreign_Reference_5_YPL- 0085.pdf	1430315	no	9
Warnings:					
Information:					
7	Foreign Reference	Foreign_Reference_6_YPL- 0085.pdf	1695355	no	12
Warnings:					
Information:					
8	Foreign Reference	Foreign_Reference_7_YPL- 0085.pdf	4661350	no	45
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Information	:				
9	Fee Worksheet (PTO-06)	fee-info.pdf	8170	no	2
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.